



1722

DOCKET NO.: 4029

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF THE APPLICATION FOR PATENT

OF: Michio OSADA et al.

| ART UNIT: 1722

SERIAL NO.: 09/705,237

| Confirmation No.: 4586

FILED: November 2, 2000

FOR: Die Used for Resin-Sealing and  
Molding an Electronic Component

COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

12/10  
7/15/03  
RECEIVED  
JUL 15 2003  
GROUP 1700  
July 9, 2003

INFORMATION DISCLOSURE STATEMENT WITH CERTIFICATE OF MAILING

Dear Sir:

- 1) This is **NOT** a Response to the Office Action of June 26, 2003.  
A Response will be filed in due course.
- 2) Pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98 applicants enclose a third Form PTO-1449, a copy of the reference listed thereon, and a copy of a Korean Office Action (and English translation thereof) issued in a counterpart Korean application on May 29, 2003.
- 3) The undersigned attorney hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement, as seen from the Korean Office Action date of May 29, 2003. Also, under 37 C.F.R. 1.97(c), this IDS is being filed before the mailing date of a Final Office Action or a Notice of Allowance. Thus, a fee is not

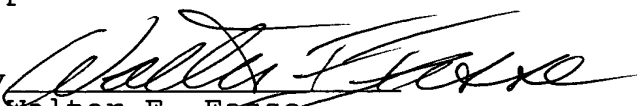
due for the submission of the present Information Disclosure Statement.

- 4) The present reference AD is accompanied by an English Abstract. Moreover, the enclosed English translation of the Korean Office Action shows why the Korean Examiner found the cited reference to be relevant. The Korean Examiner's remarks are not ratified or adopted as accurate, but are submitted for the U. S. Examiner's consideration as to the relevance of the reference.
- 5) The second reference cited in the Korean Office Action, namely JP 10-286845, has already been cited herein as reference AC in our IDS of November 4, 2002.
- 6) Applicants respectfully request that the Examiner consider all references of record, return an initialled copy of the enclosed Form PTO-1449 and ensure that all references of record are printed on any patent issuing from this application.

Respectfully submitted,

Michio OSADA et al.  
Applicant

WFF:ar/4029  
Encls.: postcard,  
Third Form PTO-1449,  
1 reference, copy of  
Korean Office Action  
with English Translation

By   
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CERTIFICATE OF MAILING:

I hereby certify that this correspondence with all indicated enclosures is being deposited with the U. S. Postal Service with sufficient postage as first-class mail, in an envelope addressed to: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450 on the date indicated below.

Anita Morse - July 9, 2003  
Name: Anita Morse Date: July 9, 2003

Sheet 1 of 1
**THIRD  
LIST OF REFERENCES CITED BY  
APPLICANT**

 OIP (REVISED FORM PTO-1449)  
 DATED: July 9, 2003

 Atty. Docket No.  
 4029

 Serial No.:  
 09/705,237

Applicant: Michi OSADA et al.

 U.S. Filing Date:  
 November 2, 2000

 Art Unit:  
 1722

**U. S. PATENT DOCUMENTS**

*EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	Cl.	Sub- Cl.	File Date

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NO.	DATE	COUNTRY	Cl.	Sub- Cl.	Trans.	
						Yes	N
AD	9 2 - 9 7 7	01/1992	Korea	-	-	x- Abst.	

**OTHER DOCUMENTS**

EXAMINER	DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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